EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	8	(("5015330") or ("5710073") or ("6143081")).PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/02/28 15:12
L2	0	(semiconductor adj wafer) with coat$3 with ((chemical adj vapor adj deposit$3) or cvd) with inject$3 with gas	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/02/28 15:14
L3	1	(semiconductor adj wafer) with coat$3 with ((chemical adj vapor adj deposit$3) or cvd) with inject$3	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/02/28 15:18
L4	221	(438/711).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/02/28 15:17
L5	922	(438/758).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/02/28 15:17
L6	0	(semiconductor adj wafer) with coat$3 with ((chemical adj vapor adj deposit$3) or cvd) with inject$3	US-PGPUB	OR	ON	2006/02/28 15:18